IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Pri rity Application Serial No	
Priority Filing Date	August 30, 2001
Inventor	
Assignee	Micron Technology, Inc.
Priority Group Art Unit	
Priority Examiner	
Attorney's Docket No	
Title: Perovskite-Type Material Forming Methods, Capacitor Dielectric Forming Methods,	
and Capacitor Constructions	_

PRELIMINARY AMENDMENT

To:

MS Patent Application Commissioner for Patents

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AMENDMENTS